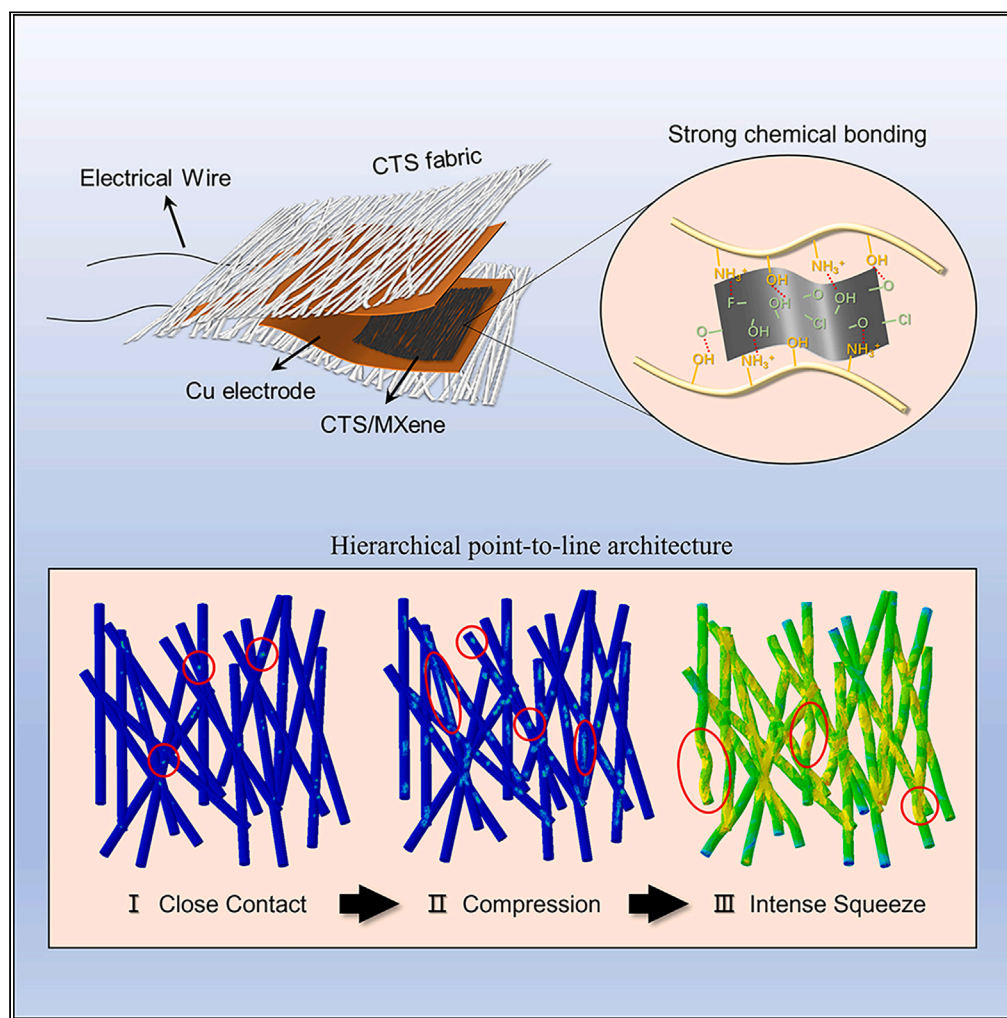


Article

High-sensitivity, ultrawide linear range, antibacterial textile pressure sensor based on chitosan/MXene hierarchical architecture



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Highlights

A 'point-to-line' architecture and a strong chemical bonding strategy is developed

The sensor exhibits high sensitivity and ultra-broad linearity range

An overall classification rate of 98.61% on six human actions is achieved

The high-performance pressure sensor shows the merit of antibacterial

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Article

High-sensitivity, ultrawide linear range, antibacterial textile pressure sensor based on chitosan/MXene hierarchical architecture

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SUMMARY

It is still a great challenge for the flexible piezoresistive pressure sensors to simultaneously achieve wide linearity and high sensitivity. Herein, we propose a high-performance textile pressure sensor based on chitosan (CTS)/MXene fiber. The hierarchical “point to line” architecture enables the pressure sensor with high sensitivity of 1.16 kPa⁻¹ over an ultrawide linear range of 1.5 MPa. Furthermore, the CTS/MXene pressure sensor possesses a low fatigue over 1000 loading/unloading cycles under 1.5 MPa pressure load, attributed to the strong chemical bonding between CTS fiber and MXene and excellent mechanical stability. Besides, the proposed sensor shows good antibacterial effect benefiting from the strong interaction between polycationic structure of CTS/MXene and the predominantly anionic components of bacteria surface. The sensor is also applied to detect real-time human action, an overall classification accuracy of 98.61% based on deep neural network-convolutional neural network (CNN) for six human actions is realized.

INTRODUCTION

The extensive developments of flexible pressure sensors have engaged new application opportunities for robotics,¹ human-machine interface,² and health monitoring.^{3,4} The working mechanism of the pressure sensors can be divided into piezoresistive,^{5–8} piezoelectric,⁹ capacitive,^{10–12} ferroelectric,¹³ and triboelectric.¹⁴ Among these pressure sensors, piezoresistive pressure sensors have been widely adopted because of their simple device structure and easy signal processing. The practical applications of piezoresistive pressure sensors lie on their sensing performance especially high sensitivity over a wide linearity for easy signal processing,¹⁵ which is mainly depending on the deformation behavior of elastomers (such as polydimethylsiloxane (PDMS),¹⁶ polyurethane (PU),^{17,18} polyimide (PI),^{19,20} etc.) as well as active materials (such as metal wires,²¹ MXene,²² carbon nanotubes (CNT),²³ graphene,²⁴ etc.).

To date, many approaches have been developed to improve these attributes. A classic way to achieve high sensitivity and linearity is to engineer these elastomers with specific patterned micro/nanostructures or random microstructures templated from natural/existing objects (such as leaf,^{25,26} abrasive paper,²⁷ or animal organ²⁸). For example, a highly sensitive bionic PDMS/CNT based piezoresistive pressure sensor was rationally designed and realized by employing the *Epipremnum aureum* leaf and sugar (83.9 kPa⁻¹ within 140 Pa).²⁹ Li et al. achieved high sensitivity piezoresistive pressure sensor by adopting the conical frustum-like PDMS/Ag microstructure (259.32 kPa⁻¹ in the range of 0–2.5 kPa)³⁰ and the spontaneously formed flower-shaped SnSe₂ nanoplates (433.22 kPa⁻¹ in the range of 0–2.4 kPa).³¹ However, the high sensitivity drastically decreases as the pressure further increases. The fabrication of these micro/nanostructured elastic polymers usually requires complex and high-cost production processes, such as UV lithography (photoresist coating, exposure, acid etching, stripping, and so on), inductively coupled plasma (ICP) etching, etc. Several advanced microstructures fabrication methods have been proposed, such as laser etching,³² which is non-toxic and fast. To prepare deformable sensors or functional circuits on 3D freeform surfaces, Yang et al.³³ developed a well-performed iontronic pressure sensor by laser-induced gradient micro-pyramids. Moreover, decoupling sensing mechanisms is crucial for multimodal sensors, methods like employing force-dependent contact spots between conductive materials and electrodes is an effective way to analyze different signals of compression, bending, and twisting.^{34,35} Supplementary work like standalone wearable devices designing is important for practical applications, especially multifunctional platform which is wireless, portable, and multimodal.^{36–38}

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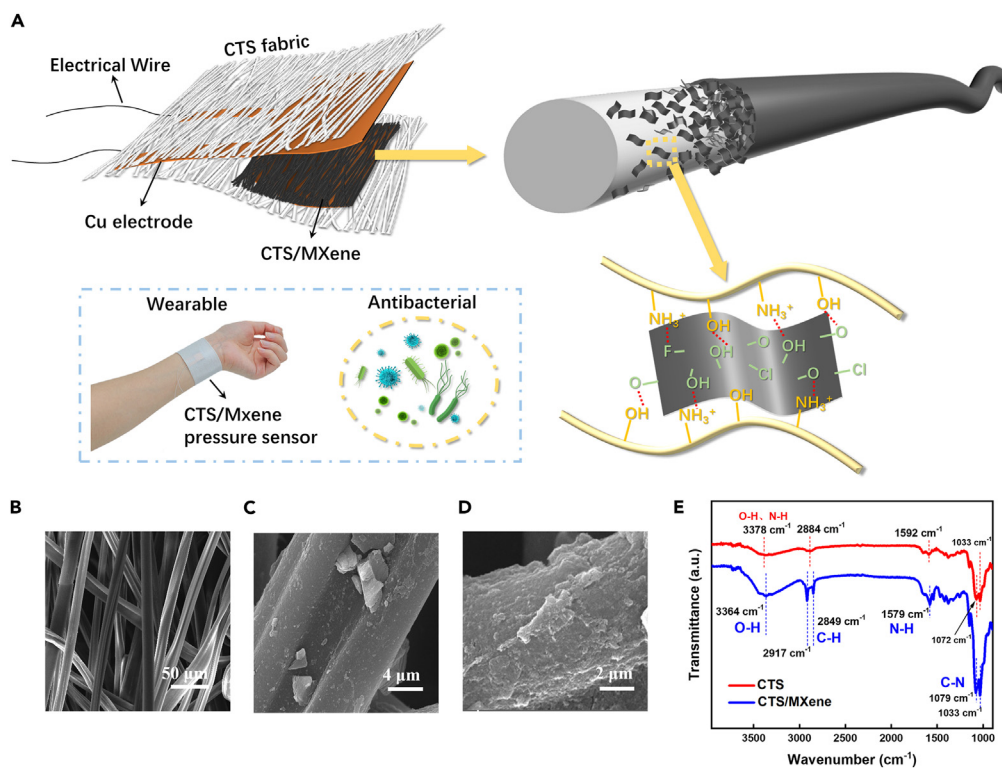


Figure 1. Fabrication process, application, and characterization of the CTS/MXene pressure sensor and CTS/MXene fabrics

(A) Structure elaboration, chemical principle and application of the CTS/MXene pressure sensor.

(B–D) Top-view SEM images of CTS, CTS/MXene (stirring) and CTS/MXene (EPD).

(E) FT-IR spectra of CTS and CTS/MXene (EPD).

Besides the requirement of micro/nanostructures, elastic modulus of the sensing material (both the elastomers and active materials) is also the key influence factor of the wide linearity. Conventional PDMS elastomers are commonly subject to the deficiency of low elastic modulus (10 kPa–10 MPa),³⁹ which may result in the saturation behavior of the pressure sensor at low-pressure levels. High elastic modulus elastomers, such as PI⁴⁰ and chitosan (CTS)^{41,42} (elastic modulus ~ GPa), are appropriate choice to achieve wide linearity. For instance, Jia et al.²⁰ reported a PI/FCNT (functional carbon nanotubes) pressure sensor with high-linearity (3380 kPa) via the point-to-point working mechanism, however, at a cost of reduced sensitivity (0.005 kPa⁻¹). Therefore, it is still a great challenge for the flexible piezoresistive pressure sensors to simultaneously achieve wide linearity and high sensitivity.

Herein, we demonstrate a thin (~0.76 mm), lightweight (~0.182 g/cm³), wearable, and antibacterial textile CTS/MXene fiber pressure sensor with high sensitivity and ultrawide linear range (Figure 1A). CTS is a natural linear polysaccharide comprised N-acetyl-D-glucosamine and β-(1–4)-linked D-glucosamine, which can be extracted by the alkaline deacetylation of chitin.^{43,44} CTS has numerous features such as antibacterial, biodegradability, cationic nature, non-allergic, and non-toxicity.⁴⁵ MXenes are a new type of two-dimensional (2D) transition metal carbides formulated as M_{n+1}X_nT_x, where M is an early transition metal, X is C and/or N, T is a surface termination O, OH, F, and/or Cl, n is 1–3.^{46,47} MXene possesses various merits such as high conductive, hydrophilic, and strong mechanical properties,⁴⁸ which have also been proven to be a good candidate for active materials attributing to their excellent diversified structure and controllable electrical properties. The designed CTS/MXene pressure sensor achieves high sensitivity (1.16 kPa⁻¹), ultrawide linear range (1.5 MPa, R² = 0.997), low fatigue over 1000 loading/unloading cycles and small hysteresis of 5.14% even under a high pressure of 1.5 MPa. This is attributed to the synergistic effect of continuous yet large variations of contacting area enabled by the hierarchical “point to line” architecture, strong chemical bonding interaction between CTS and MXene and excellent mechanical stability (Figure 1A). The proposed CTS/MXene pressure sensor also displays good antibacterial effect benefiting from the strong interaction between polycationic structure of CTS/MXene and the predominantly anionic components of bacteria surface. Furthermore, the sensor is applied to recognize human action, an overall classification accuracy of 98.61% for six human actions is realized through a deep neural network based on convolutional neural network (CNN).

RESULTS AND DISCUSSION

For fabric flexible pressure sensor, a uniform and conductive structure is essential. CTS fabric provides a stable hierarchical network structure which ensures the adsorption of conductive active substances. MXene is a beneficial conductive nanomaterial, which also has excellent mechanical properties. The compression of CTS fabrics wrapped with MXene nanoplates causes gradually increasing contact area, result in

resistance reduction. Figure S1 shows the optical micrographs and 3D stereoscopic topography of the CTS fabric. Figure 1B represents the corresponding scanning electron microscope (SEM) image. Hierarchical, porous fiber network with certain orientation is observed, providing both the point-to-point and line-to-line contacting modes under pressure. Compared with the conventional point-to-point contacting mode, these diversified modes may be beneficial to enhance the sensitivity and sensing range. Electrophoretic deposition (EPD) process was employed to construct the CTS/MXene fiber composites (see STAR methods). A uniform and conductive CTS/MXene composite was obtained and the degree of uniformity is much better than that of the frequently used stirring process (MXene tends to agglomerate and gather at the surface or the gap of the fiber network), as observed in Figures 1B–1D. Fourier transform infrared spectroscopy (FT-IR) spectra are adopted to probe the interactions between CTS and MXene (Figure 1E). Several characteristic adsorption peaks of CTS were noted at 3378 cm^{-1} , 2884 cm^{-1} , and 1592 cm^{-1} , corresponding to the stretching vibrations of O–H and N–H, C–H, and N–H, respectively. The bands centered at 1072 cm^{-1} and 1033 cm^{-1} are due to C–N stretching vibration. For CTS/MXene, the broadband at 3378 cm^{-1} shifted to 3364 cm^{-1} and the intensity is significantly reduced, which reveals that hydrogen bonding forms among the surface functional groups such as –OH, =O and $-\text{NH}_3^+$ within CTS and MXene (Figure 1A).^{49,50} Moreover, in the range of $2950\text{--}2800\text{ cm}^{-1}$, new peaks appeared at 2917 cm^{-1} and 2849 cm^{-1} , which can be attributed to symmetric and asymmetric stretching vibrations of C–H bonds on MXene functionalized surfaces.^{51–54} Besides, the absorption band of N–H shifted to 1579 cm^{-1} and the C–N stretch vibration absorption band shifted to 1079 cm^{-1} . This could be also ascribed to the strong chemical interaction between CTS and MXene, originated from the surface functional groups (–OH, =O, –F, –Cl) of delaminated MXene nanoplates ($\text{Ti}_3\text{C}_2\text{T}_x$) through the etching of MAX (Ti_3AlC_3) precursors in LiF/HCl mixing solution and ultrasonic-assisted treatment, as well as abundant active surface groups of CTS (–OH, $-\text{NH}_2$).

To evaluate the property of the CTS/MXene pressure sensor, we set up an intelligent testing and data-acquisition platform to perform pressure loading and record the corresponding current signal (see STAR methods). The effects of the MXene morphology and doping technique, as well as EPD time on the sensitivity and linearity of the proposed CTS/MXene pressure sensors were systematically studied. Figure S2 is the optical image of the final encapsulated sensor device. The size of the sensor device is 35 mm (length) × 35 mm (width) × 0.76 mm (thickness) for all the encapsulated CTS/MXene pressure sensors (see STAR methods). Figure 2A shows the relative change of the current ($\Delta I/I_0$) as the pressure load changes, where $\Delta I = I - I_0$, I is current at load pressure, I_0 is the initial current. The sensitivity is defined by the following equations: $S = (\Delta I/I_0)/\Delta P$, where ΔP is the pressure change. It is clear that all the CTS/MXene pressure sensors with EPD process exhibit higher sensitivity and broader sensing range than that with stirring process. Furthermore, we can see that EPD time plays critical roles on both the sensitivity and linearity of the CTS/MXene (EPD) sensor device. First of all, the CTS/MXene (EPD) with 1 h EPD time possesses the highest performance with the sensitivity of 1.16 kPa^{-1} over a whole ultrawide linear range of 1.5 MPa. The initial current is quite small ($\sim 0.9\text{ }\mu\text{A}$), making the device sensitive enough. When subjected to a pressure of 1.5 MPa, the current reaches 1.57 mA. Sample-to-sample variations of pressure sensitivity have shown in Figure S3, revealing good uniformity between different CTS/MXene-3 (EPD-1h) pressure sensors. The maximum sensing pressure of CTS/MXene pressure sensor is 3 MPa, as shown in Figure S4. The best linear range is 0–1.5 MPa, and from 1.65 MPa, the current change rate tends to saturate. In the low-pressure region, our pressure sensor can reach a limit of detection as low as 5.14 Pa with a piece of PEEK film (Figure S5). The CTS/MXene (EPD) pressure sensor (EPD time = 0.5 h) shows a relative low sensitivity (0.53 kPa^{-1}). This is mainly due to that the CTS fibers are only partially coated by the MXene nanoplates, in other words, the effectively established conductive path is not enough (Figure S6). As the EPD process time increases to 1.5 h, the CTS/MXene (EPD) sensor shows the lowest sensitivity (0.41 kPa^{-1}), which can be ascribed to the relatively high initial current (low initial resistance) and fewer conductive paths increasing. Under the electric field, the excess MXene nanoplates not only wrap around CTS fibers, but also fill the fiber gaps due to the stacking via van der Waals forces.^{46,55,56} As shown in Figure S6, when EPD time = 1.5 h, MXene nanoplates fill most of the fiber voids and gaps between fiber layers, which greatly reduced the initial resistance of the whole device. The initial resistance is about 526 k Ω ($R_0 = 1\text{ V}/1.9\text{ }\mu\text{A} = 526\text{ k}\Omega$). Under the external pressure of 1.5 MPa, the current could reach $\sim 1.17\text{ mA}$. However, the current change ($\Delta I/I_0$) is not at par with that of CTS/MXene (EPD) sensor with 1 h EPD process. Table S1 organizes and discusses the effects of four CTS preparation methods on initial conductivity, as well as the corresponding morphology images of the obtained CTS/MXene functional layers. Figure 2B shows the $\Delta I/I_0$ versus pressure curves under loading and unloading in the whole 1.5 MPa working pressure region. The hysteresis of the CTS/MXene (EPD) pressure sensor is estimated to be 5.14%, which is calculated by the formula $\xi_H = \frac{\Delta H_{\max}}{Y_{F.S.}}$, where ΔH_{\max} is the maximum difference of the current output between forward and reverse strokes, $Y_{F.S.}$ is the full-scale output current value, as shown in Figure S7. The value is relatively small compared to previous reported piezoresistive pressure sensor. This is because the porous nature of the CTS/MXene architecture that minimizes viscoelasticity as well as its relatively large elastic modulus. To further verify the operational stability and reproducibility of the proposed CTS/MXene (EPD) pressure sensor, different pressures ranging from 80 kPa to 1.5 MPa over 7 on/off cycles were applied to the sensor, as shown in Figure 2C. It is obvious that the CTS/MXene (EPD) sensor responds to the pressure repeatedly with stable current signals under each external pressure, revealing that the proposed sensor could work steadily from kPa to MPa range. The robust repeatability and reliability of the proposed sensor was further confirmed by the repeated high pressure (1.5 MPa) loading and unloading experiments (Figure 2D). Inset of Figure 2D shows the magnified sensor responses at different time intervals. During 1000 repeated cycles, it is observed that there is no obvious signal degradation, attributing to the strong chemical interaction between CTS and MXene as well as outstanding compressibility for CTS and CTS/MXene composites. For mechanical deformation, the proposed CTS/MXene (EPD) pressure sensor device also exhibits excellent repeatability during cyclic bending test and twisting test, as depicted in Figure S8. To further explore the underlying mechanism of the good robustness of the pressure sensor, CTS fiber and CTS/MXene fiber composites were subjected to cyclic compression tests. The results are shown in Figure S9. It is found that both CTS and CTS/MXene exhibits a small plastic strain of 1.5% and 0.5% after 100 cycles at the stress of 1.33 MPa, indicating the outstanding cyclic compressive stability. Figure S10 is the current–voltage (I – V) curves of the sensor

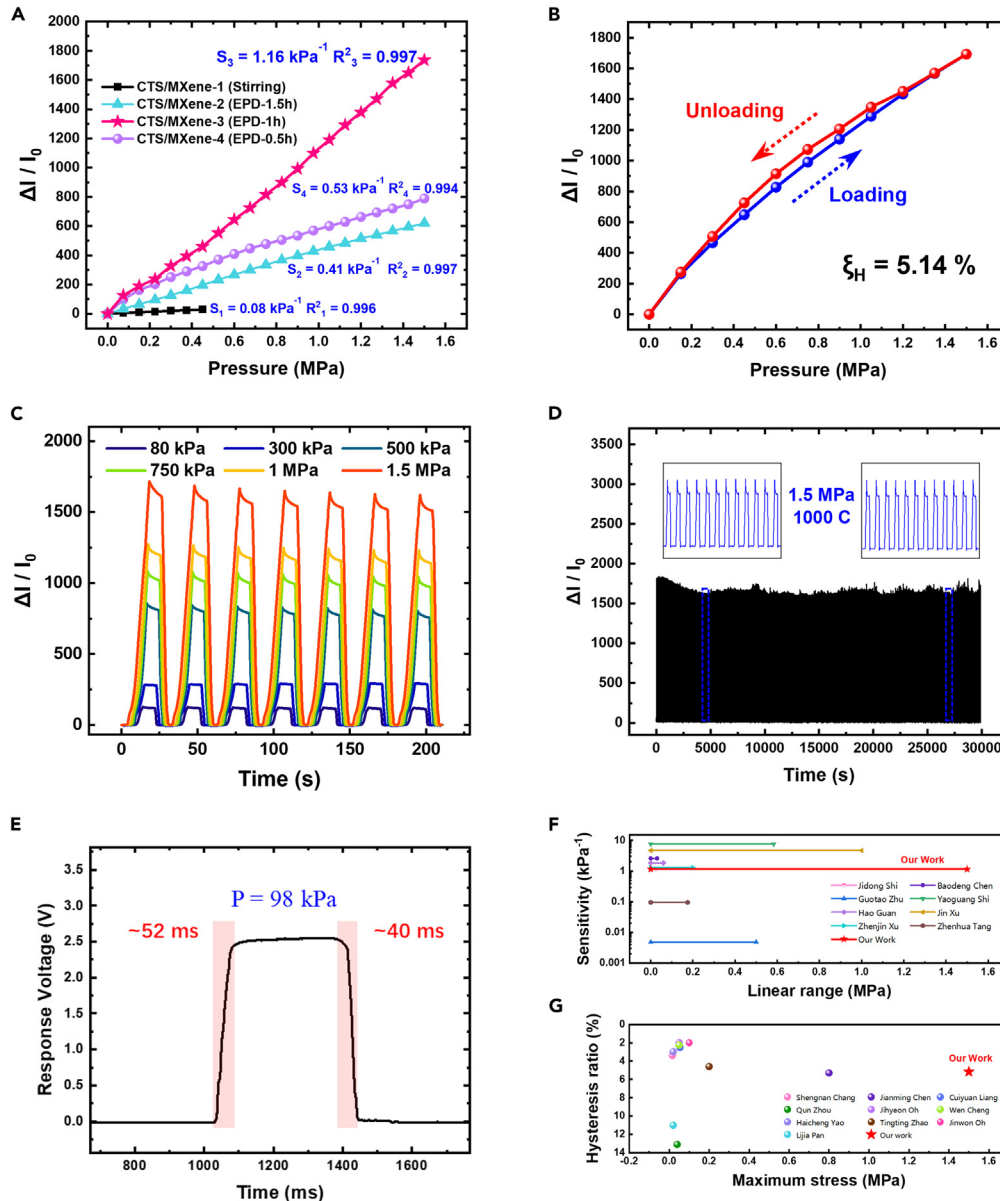


Figure 2. Pressure sensing performance of the fabricated CTS/MXene pressure sensors

(A) Relative current change ($\Delta I/I_0$) versus the pressure of the CTS/MXene (stirring), CTS/MXene (EPD-1.5h), CTS/MXene (EPD-1h), CTS/MXene (EPD-0.5h) pressure sensor.

(B) Electrical hysteresis of the CTS/MXene pressure sensor obtained during loading and unloading process in the range of 0–1.5 MPa.

(C) Multiple cycles of the pressure sensor response under different pressures ranging from 80 kPa to 1.5 MPa.

(D) Test of durability of 1000 cycles under 1.5 MPa.

(E) Response and recovery time of the pressure sensor under the pressure of 98 kPa.

(F) Comparison of sensitivity and linear sensing range for different piezoresistive sensors.

(G) Comparison of hysteresis ratio and maximum stress for different piezoresistive sensors.

device under different pressure ranging from 50 kPa to 1.5 MPa. The linear relation of the I–V curves indicates the ohmic contacts were formed between CTS/MXene and copper electrodes. Besides, the slope of the I–V curves increases with the increasing pressure, suggesting the continuous decrease of the pressure sensor’s resistivity. All these experimental results indicate the excellent stability and reproducibility of the proposed sensor. Response time is another key parameter of the pressure sensor. The proposed CTS/MXene (EPD) sensor device offers a fast response and relaxation time of 52 ms and 40 ms under the applied pressure of 98 kPa (Figure 2E), enabling the sensor to monitor the physical signals in real time. The response and relaxation time of the sensor under different pressure is provided in Figure S11. As summarized

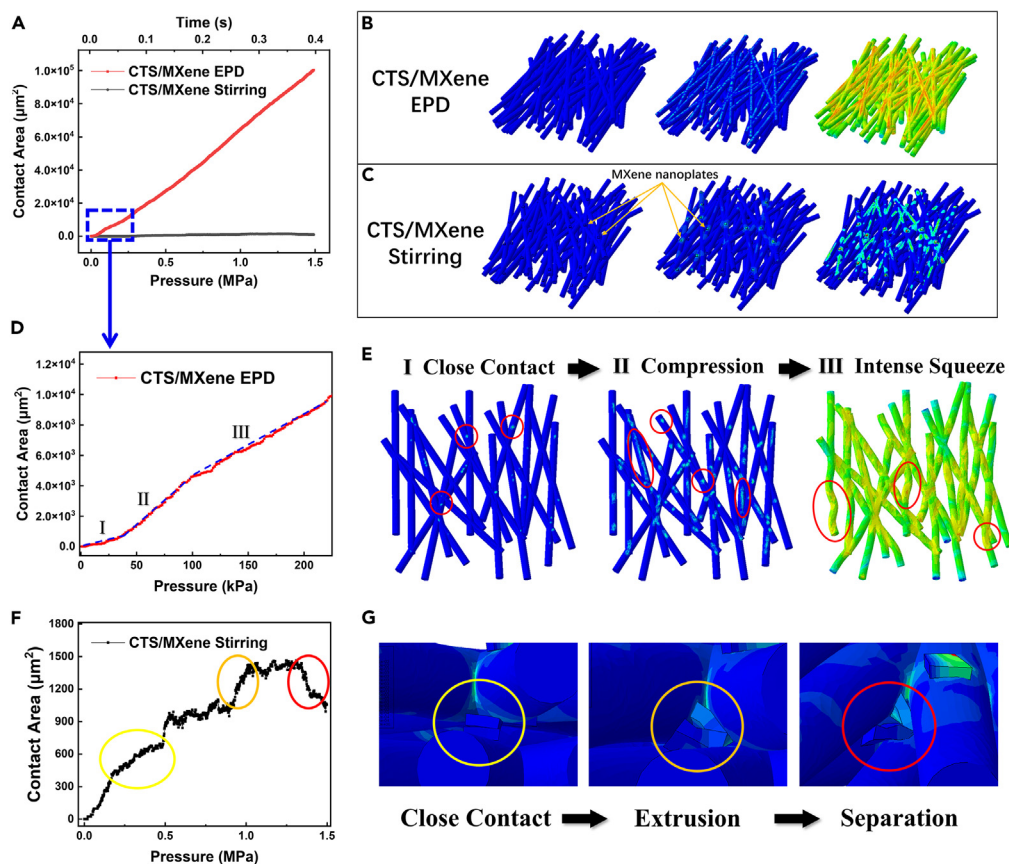


Figure 3. Finite element analysis of the CTS/MXene pressure sensor

- (A) Contact area as a function of time and pressure for CTS/MXene (EPD) pressure sensor and CTS/MXene (stirring) pressure sensor.
 (B and C) Microscopic deformation process for the model with CTS/MXene (EPD) and CTS/MXene (stirring), respectively.
 (D) Contact area as a function of pressure for CTS/MXene (EPD) pressure sensor in the range of 0–250 kPa.
 (E) Microscopic deformation process for the model with CTS/MXene (EPD), the deformation process can be divided into three stages (close contact-point to point contact, compression-point to point contact and line to line contact, intense squeeze).
 (F) Contact area as a function of pressure for CTS/MXene (stirring) pressure sensor in the range of 0–1.5 MPa.
 (G) Microscopic deformation process for the model with CTS/MXene (stirring), the deformation process can be divided into three stages (close contact, extrusion, separation).

in Figures 2F and 2G, our CTS/MXene pressure sensor shows greater advantages of high sensitivity within an ultrawide linear range and low hysteresis ratio under incomparably high stress, compared to existing piezoresistive pressure sensors reported in recent literatures.^{5,57–72} Furthermore, the complete performance parameters have been benchmarked and compared with other flexible pressure sensors in Table S2.

To better understand the sensing mechanism for CTS/MXene pressure sensor with EPD and stirring process, finite element modeling (FEM) was employed to analyze the dynamic working process of pressure sensors during compression by the software Abaqus. According to the SEM results shown in Figures 1B–1D, we established models for CTS fabrics, MXene nanoplates aggregation, and CTS/MXene (EPD) fabrics. The setup details of simulation are shown in Figures S12–S19. As schematically shown in Figure S6A, agglomerated MXene nanoplates adsorbed onto fibers physically, resulting in few conductivity paths. In contrast, the vast majority of the CTS/MXene fibers (Figure S6C) became conductive in case of 1-h EPD, which benefit from MXene nanoplates adhered to CTS fiber evenly under the action of hydrogen bonding. Therefore, we established conductive models for CTS/MXene (EPD) and CTS/MXene (stirring) in the mode of fibers-to-fibers and nanoplates-to-nanoplates. Figure 3A displays conductive contacting area as a function of time and pressure, collected from the dynamic microscopic deformation processes for two models (Figures 3B and 3C). The relationship between the contact area and conductivity of the sensor is illustrated in Figure S20. The conductivity of CTS/MXene piezoresistive layer is calculated by following formula: $R = \rho L/S$, where R is the total resistance, L is the thickness of the piezoresistive layer, and S is the area of conductive parts. When pressure is applied, the resistance changes from infinite ($+\infty$) to R_c , fibers are deformed, resulting in larger contact area (S) and smaller resistance (R), as shown in Figure S20B. Meanwhile, the thickness of the piezoresistive layer (L) is decreasing. As a consequence, the total resistance of CTS/MXene piezoresistive layer decreases, improving the conductivity of the device. For the fibers-to-fibers model, the whole fiber layers stressed uniformly under external pressure, indicating large contact area change and extremely high sensitivity in a linear manner. As the pressure increases from

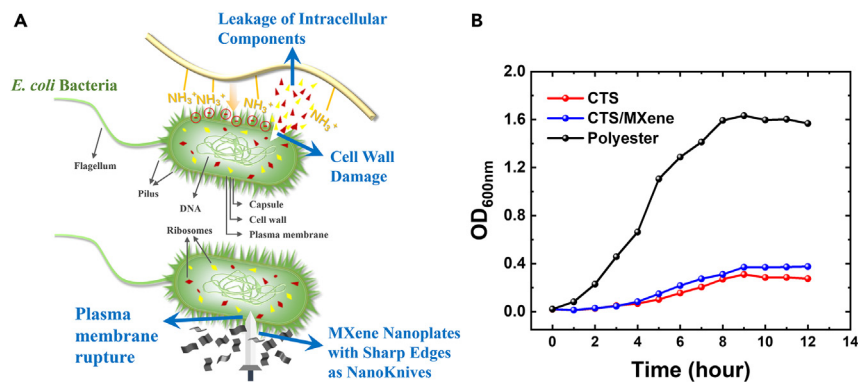


Figure 4. Antibacterial properties of CTS fabric and CTS/MXene fabric

(A) The schematic illustration of antibacterial mechanism of CTS and MXene nanoplates.

(B) Antibacterial experiment results of CTS fabrics, CTS/MXene fabrics and polyester fabrics for *E. coli*.

0 to 30 kPa, fiber layers contact with each other in the form of point-to-point, leading to the contact area increment for stage I (Figures 3D and 3E, Video S1). The contact area increases rapidly in the stage II, in which fibers were compressed in the range of 30–100 kPa, ascribing to both the increase of point-to-point contacts and line-to-line contacts. For stage III, fibers will be squeezed when the pressure is greater than 100 kPa. The continuous deformation of fibers, the multiple contacting modes, and high modulus property of CTS/MXene fiber enables the high sensitivity and wide linear range of the pressure sensor. However, for the nanoplates-nanoplates model, the contact mode of nanoplate pairs starts from close contact to extrusion to separation, directly leading to the small contacting area (Figure 3F), uncertain conductive paths or even broken circuits (Figures 3G, Video S2).

Pressure sensors with CTS as the encapsulation layer are more advantageous when applied to wearable devices, because of its merit of antibacterial properties brought by cationic groups on the surfaces of CTS.^{43,73,74} Furthermore, MXene was also proven to be antibacterial in previous studies.^{75–77} To explore the antibacterial properties of CTS and CTS/MXene, a shake flask method is explored, making full contact between bacteria and the fabric because of the innately antibacterial property of CTS. *E. coli* is cultured in test tubes on a bacterial shaker incubator at 37°C, containing CTS fabrics, CTS/MXene fabrics and polyester fabrics as blank control group, respectively. During 12 h cultivation, the absorbance (OD) of the bacterial solution was measured, as shown in Figure 4B. The OD₆₀₀ stands for the optical density of 600 nm. Obviously, the bacterial solution with polyester shows the highest absorbance intensities of 1.63 for *E. coli* at the ninth hour, considered to be the maximum number of bacteria without any suppression. In comparison, both the CTS fabrics and CTS/MXene fabrics showed a strong inhibitory effect in the first 3 h, ascribing to the destructive effect of cationic groups of CTS on bacteria. As shown in Figure 4A, the interaction between polycationic structure of CTS and the predominantly anionic components of bacteria surface leads to changes in permeability, leakage of intracellular components and death of the cell. Also, owing to the close contact between bacteria and fabrics during violent shaking, sharp edges of MXene nanoplates could rupture the bacterial membrane, which also played a certain inhibitory role. However, the solution absorbance intensity started to grow for CTS fabrics and CTS/MXene fabrics at the fifth hour, which means the antibacterial activity started descending. From the ninth hour, the number of *E. coli* no longer grew any more. The final solution absorbance intensities were 0.27, 0.38, and 1.57, corresponding to CTS fabrics, CTS/MXene fabrics and polyester fabrics, respectively.

For actual wearable applications, we explore the sensor's ability as a skin-mountable human motion detector to real-time monitor biophysical signals. In the test, the fabricated CTS/MXene pressure sensor was attached to various parts of human body, as shown in Figures 5A–5F, including finger joint, arm muscles, palm, wrist joint, neck, and ankle joint. For all the repetitive dynamic flexion and straightening motions of these positions, the CTS/MXene pressure sensor is highly responsive. In cycling test, the response and relaxation behaviors are proved to be reproducible. Deep learning has wide applications in human motion recognition, machine translation and behavior analysis. A multiscale kernel based residual CNN was proposed by Liu et al.⁷⁸ Figure S21 depicts the structure and parameters of CNN. Firstly, the multiscale kernel algorithm is applied in the CNN architecture to ensure that different signal intensities are captured. The design of the three-head network is sufficient to ensure that the network can handle different signal intensities. Secondly, in order for the architecture to extract signal features from deep and hierarchical representation spaces, sufficient network depth is required. Therefore, residual learning is embedded into a multiscale kernel CNN to avoid degradation problems and prevent features from being effectively extracted. Based on the previous structural design, the structure of this multi-time scale convolutional network model is very clear, and it can effectively classify input signals. Due to the match with the sequence properties of the sensor signals, we used CNN for sensor-based human motion classification. We tested the prediction ability of the neural network model under different training epochs and different hyperparameters such as learning rate, by monitoring the accuracy in epochs in real time. By training the network model based on our collect 2120 samples, we have achieved a recognition accuracy of 98.61% (Figure 5H). The final model was trained for 20 epochs, and the initial learning rate was 0.001. The accuracy of the third epoch was about 65%, and the accuracy of the seventh epoch reached 90%. The final accuracy was stable at about 98%. We also tested the recall rate, F1 score and other classification model indicators. The

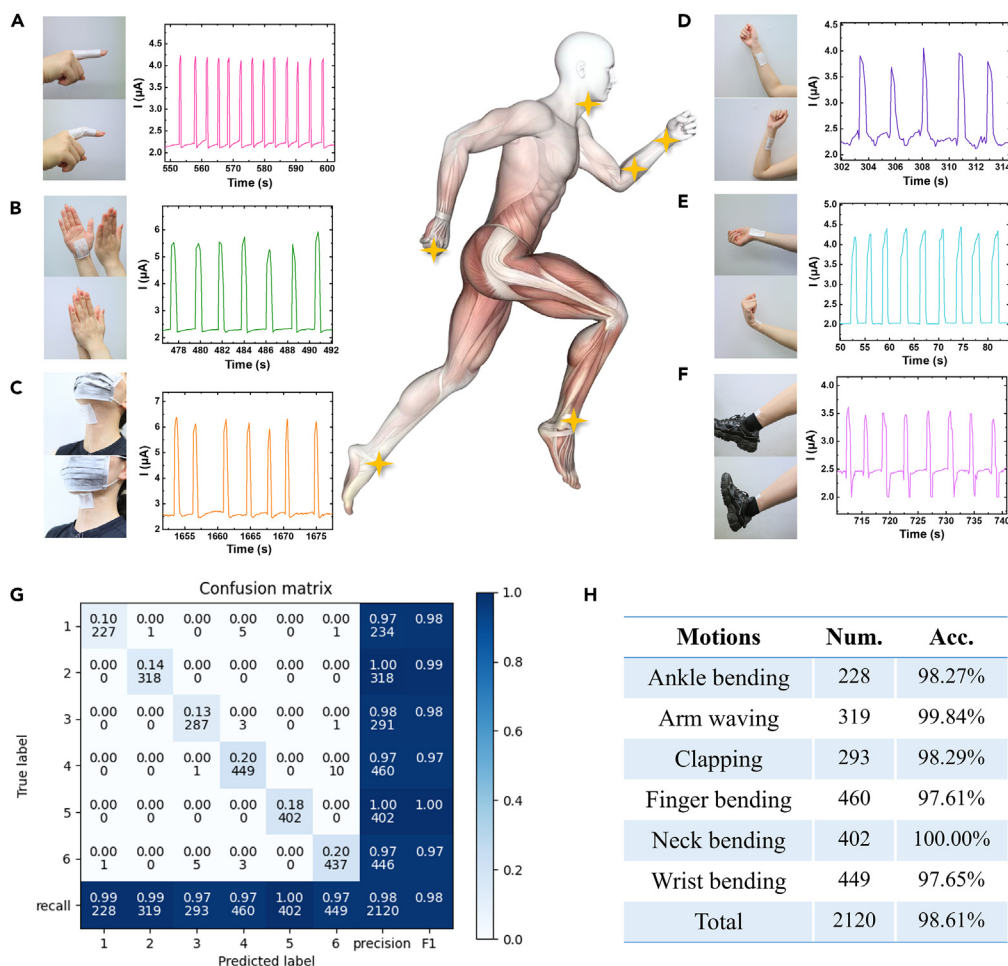


Figure 5. Human action detection and recognition by the CTS/MXene pressure sensor

(A–F) Human action detection: monitoring finger bending, clapping, neck bending, arm waving, wrist bending, and ankle bending.

(G) The confusion matrix for biophysical action-level classification by CNN.

(H) The statistics of the collected human actions and the accuracy for each one. The total accuracy is 98.61%.

recall rate was 98.5% and the F1 score reached 98.6%. A combination of multiple indicators determined that the model did not have overfitting problems. 5-fold cross-validation was used to train and test our model. In Figure 5G, we show the results tested on the training set, and the ratio of training set to test set is 4:1. In addition, we characterized the sensor's performance by driving a truck over the pressure sensor (~700 kPa) repeatedly, as shown in Figure S22. It is found that the sensor responds quickly and stably under the repeated tests, endowing its good applicability in real-world high pressure scenarios.

Conclusion

In summary, CTS/MXene fiber composites were constructed by the facile EPD technique and applied in the piezoresistive sensor. Benefiting from the hierarchical yet porous architecture, point-to-line contacting modes, strong chemical interaction, high modulus, as well as excellent mechanical stability of the CTS/MXene fiber, the fabricated pressure sensor displayed outstanding performance including high sensitivity (1.16 kPa^{-1}) within ultrawide linear range (1.5 MPa), a small hysteresis of 5.14% and a low fatigue over 1000 loading/unloading cycles under 1.5 MPa pressure load. The sensor device also possesses good antibacterial effect ascribing from the strong interaction between CTS/MXene and bacteria surface. In addition, the sensor could also be applied in various human action detection. With the help of CNN deep neural network, the sensor could recognize the human action with high accuracy of 98.61%.

Limitations of the study

We did not investigate decoupled sensing mechanisms of multimodal sensors, as the sensor responds to both pressure and mechanical strain from bending/twisting. The demonstration that directly leverages the antibacterial properties is still needed to be further investigated.

STAR★METHODS

Detailed methods are provided in the online version of this paper and include the following:

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- METHOD DETAILS
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 - Encapsulation of CTS/MXene piezoresistive pressure sensor
 - Characterization and test
 - FEA simulation

SUPPLEMENTAL INFORMATION

Supplemental information can be found online at <https://doi.org/10.1016/j.isci.2024.109481>.

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AUTHOR CONTRIBUTIONS

M.G. and X.Z. contributed equally to this work. Conceptualization, M.G., X.Z., and M.C.; methodology, X.Z., J.S., Y.D., and Z.W.; software, M.G. and B.Z.; validation, R.X. and Y.S.; formal analysis, J.L.; investigation, Y.S. and J.G.; writing – original draft, M.G.; writing – review and editing, Lei Wei and M.C.; funding acquisition, C.Y. and M.C.; resources, Y.H., G.G., and Lei Wang; supervision, Lei Wei and M.C.; project administration, Z.W.

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The authors declare no competing interest.

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STAR★METHODS

KEY RESOURCES TABLE

REAGENT or RESOURCE	SOURCE	IDENTIFIER
Bacterial and virus strains		
Escherichia coli	BNCC	BNCC336902
Chemicals, peptides, and recombinant proteins		
Chitosan	Shanghai Aladdin Biochemical Technology Co., Ltd.	CAS: 9012-76-4
MXene	Foshan Xinxi Technology Co. Ltd.	N/A
Software and algorithms		
Abaqus 2022	Dassault Systèmes	https://www.3ds.com/products/simulia/abaqus

RESOURCE AVAILABILITY

Lead contact

Further information and requests for resources and reagents should be directed to and will be fulfilled by the Lead Contact, Ming Chen (ming.chen2@siat.ac.cn).

Materials availability

This study did not generate new unique reagents.

Data and code availability

All data reported in this paper will be shared by the [lead contact](#) upon request.

This paper does not report original code.

Any additional information required to reanalyze the data reported in this paper is available from the [lead contact](#) upon reasonable request.

METHOD DETAILS

Fabrication of CTS spunlace nonwoven fabrics

First, 100 g CTS with a DA of 95% is dissolved in 1.26 L of aqueous acetic acid solution to obtain CTS solution with concentration of 8.0%–8.5% wt. Then, the CTS solution is transferred to the wet spinning machine container and stirred for 12 h. After stirring, the solution is heated up to 60°C and immediately ejected through a jet nozzle with 20 μm diameter holes into the coagulation bath which composed of 0.5 M NaOH/10% EtOH and heated up to 30°C. The as-spun fibers are washed in a 30°C water bath and in three 20°C water baths. Afterward, the CTS fibers pass the air-drying units four times and are wound up to bobbins at a take-up speed up to 25 m/min. Finally, arrange the fibers in the water tank according to a certain orientation and bond them at 30 bars water pressure on both sides of the fabrics to get CTS spunlace nonwoven fabrics.

Preparation of CTS/MXene (EPD), CTS/MXene (stirring) functional layer

MXene was purchased from Foshan Xinxi Technology Co. Ltd., which is LiF/HCl-etched. CTS/MXene (EPD): Firstly, 0.2 g MXene was dispersed in 200 mL of deionized water and sonicated for 20 min to obtain MXene/deionized water electrolyte solution. Secondly, 10 mm (length) × 10 mm (width) CTS fabric was prepared, sticking on the surface of a piece of stainless steel. The piece of stainless steel with CTS fabric was placed in the MXene/deionized water electrolyte solution as the anode, and another piece of stainless steel was placed at a fixed distance from the anode as the cathode. The electrophoretic deposition (EPD) process lasted for 0.5 h, 1 h and 1.5 h under a direct current of 5 V, especially (Figure S23). Finally, the prepared CTS/MXene (EPD) fabric was dried at 60°C for 30 min to obtain CTS/MXene (EPD) functional layer. CTS/MXene (stirring): CTS fabric of the same size was immersed in the above MXene/deionized water electrolyte solution and stirred using a magnetic stirrer for 1 h. The CTS/MXene (stirring) fabric was then dried at 60°C for 30 min to obtain CTS/MXene (stirring) functional layer.

Encapsulation of CTS/MXene piezoresistive pressure sensor

A pair of copper foils with suitable shape were placed on both sides of the functional layer. CTS fabrics as encapsulation were cut into two pieces of suitable size according to the needs, placed on both sides of the copper foils. Two layers of CTS fabrics were strong bonded with a hot melt adhesive lining in the middle.

Characterization and test

The microtopography of the CTS and CTS/MXene functional layer was characterized by VEGA3 TESCAN. For FTIR measurement, Frontier was used. The compression test used a JISC MAX-1kN-P-2 automatic load tester. An intelligent testing and data-acquisition platform was designed (Figure S24). The pressure test was given by a pressure meter from Dongguan Zhiyu Precision Instrument Co, Ltd., and all the current data caused by changing pressure processes were collected by a semiconductor parameter analyzer Keithley 2400 series. An oscilloscope (LUCK-3, digital storage oscilloscope, Chengdu Rongte Instrument Co., Ltd.) was used to measure the response time and the recovery time. For the detection limit test, we first put a polished glass slide (~456 Pa) on the fabricated pressure sensor, and then put a piece of PEEK film on the glass slide. With the glass slide, the initial current is 8.5 μ A. There are two purposes of this method: (1) make the response current more stable, (2) make the applied pressure more even in consideration of the uneven contact surfaces of the curved PEEK film. With regard to the test on the pressure sensors' response and recovery time, we released a 2 kg weight, a 1 kg weight and a 5 g glass piece on the pressure sensor, respectively. The oscilloscope (LUCK-3, digital storage oscilloscope, Chengdu Rongte Instrument Co., Ltd.) was used for collecting the response voltage data.

FEA simulation

In order to theoretically study the working mechanism and sensing performance of the pressure sensor, Abaqus 2022 software was adopted in the simulation. Both the model building and further analysis was conducted with Abaqus 2022 software. The CTS fabric was modeled as a homogeneous isotropic elastic material with Young's modulus $E = 2.06$ GPa, and Poisson's ratio $\nu = 0.4$.